



#11/3  
2/17/00  
TIA

In re Application of: J. White, et al.

§§

Group Art Unit: 2824

Serial No.: 09/082,483

Examiner: P. Luu

Filed: May 20, 1998

For: **Modular Substrate  
Processing System**

Assistant Commissioner for Patents  
Washington, D.C. 20231

CERTIFICATE OF MAILING  
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited on 2/10/00, with the U. S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

2/10/00 D. Burt  
Date Signature

Dear Sir:

## RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

In response to the Office Action dated January 20, 2000, having a one-month response period set to expire on February 20, 2000, the Applicants elect claims 1-45, 47-58. —

**In the claims:**

Please cancel claim 46 without prejudice.

RECEIVED  
FEB 15 2001  
TC 2303 MAIL ROOM

## REMARKS

This response is intended as a full and complete response to the Office Action dated January 20, 2000. Restriction to one of the following inventions is required under 35 U.S.C. § 121:

I. Claims 1-45, 47-58, drawn to an apparatus for performing a process, classified in class 257, subclass 437.